



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ma, et al.

Application No.: 09/374,502

Confirmation No.: 3832

Filed: August 13, 1999

For: Isolation Structure Configurations for
Modifying Stresses in Semiconductor
Devices

Examiner: Jesse Fenty

Group Art Unit: 2815

Attorney Docket No.: 42390.P6623

CERTIFICATE OF MAILING

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RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 4, 2003, please amend the above-
identified application as follows:

Remarks/Arguments begin on page 2 of this paper.